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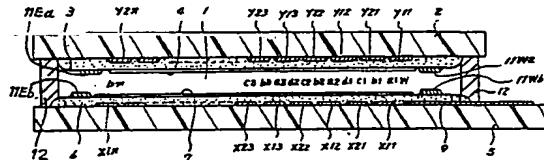
(71) Applicant: FUJITSU LIMITED, 1015, Kamikodanaka
Nakahara-ku, Kawasaki-shi Kanagawa 211 (JP)

(72) Inventor: Sei, Seto, 22-2, Takaoka 3-chome Okubo-cho,
Akashi-shi Hyogo 674 (JP)
Inventor: Maseyuki, Wakitanl, 39-5, Nodera Inami-cho,
Kako-gun Hyogo 675-11 (JP)
Inventor: Ken-ichi, Oki, 5-11, Chigusa 1-chome,
Takarazuka-shi Hyogo 665 (JP)
Inventor: Shoshin, Miura, 4-8, Kaminotani 7-chome
Suma-ku, Kobe-shi Hyogo 654 (JP)
Inventor: Hisashi, Yamaguchi, 1179-98, Rokubuchi
Inami-cho, Kako-gun Hyogo 675-11 (JP)
Inventor: Yoshinori, Miyashita, 1075, Shirakuni,
Himeji-shi Hyogo 670 (JP)
Inventor: Tsutae, Shinoda, 11-10, Takacka 3-chome
Okubo-cho, Akashi-shi Hyogo 674 (JP)
Inventor: Kazuo, Yoshikawa, 3-4-34-218, Seiryodai
Terumi-ku, Kobe-shi Hyogo 655 (JP)
Inventor: Keizo, Kurahashi, 11-21, Hontamon 3-chome
Terumi-ku, Kobe-shi Hyogo 655 (JP)
Inventor: Toyoshi, Kawada, 56-203, Akibadai 1-chome
Terumi-ku, Kobe-shi Hyogo 673-02 (JP)

(74) Representative: Descourtieux, Philippe et al, CABINET
BEAU de LOMENIE 55 rue d'Amsterdam, F-75008 Paris
(FR)

(54) Self-shift type gas discharge panel.

(57) An AC memory driving type self-shift type gas discharge panel comprises at least one shift channel, consisting of regular arrangement of write discharge cell (W) and shift discharge cells (a₁, b₁, c₁, d₁, a₂ . . .) and charge leak conductive layers (11Wa, 11Wb, 11Ea, 11Eb) which does not contribute to generation of discharge are provided adjacent to the discharge cells at both edges of the shift channel in order to leak abnormal charges accumulated at said edges and to prevent spurious discharges.



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Self-shift type gas discharge panel

This invention relates to an improved AC memory driving type self-shift type gas discharge panel with at least one shift channel consisting of a regular arrangement of a plurality of shift discharge cells formed by opposing shift electrodes which are sequentially and regularly connected to a plurality of bus, which face a gas discharge space and which are provided with a coverage of dielectric layer for charge accumulation, and with a write discharge cell formed by the provision of a write electrode at one end of said shift channel. More specifically the present invention relates to a new type panel structure wherein accidental abnormal discharges caused by deviated abnormal charges can be suppressed.

The self-shift type gas discharge panel is classified as an AC memory driving type plasma display and is used to directly shift the information written in the form of discharge spots with an unchanged pattern in order to obtain stationary display at a predetermined position. The electrodes of such a panel are naturally covered with the dielectric layer in order to attain the memory function. Presently, with panels having such a structure, a problem exists which consists in that accidental generation of abnormal discharge during the operation causes disturbance of the display information and breakdown of dielectric layer.

An abnormal discharge takes such a form that it appears around the discharge spot group corresponding to display information in the form of unit discharge spot or appears as a comparatively large light emitting pattern after it having emitted light momentarily like a lightning.

Such an accidental abnormal discharge is particularly more distinctive when employing the drive

method of so-called wall charge transfer system where a combination of wall charges is positively used for the shift operation as indicated in U.S. 3,781,600 by Coleman et al., than when employing the drive method of so-called space charge coupling system where the coupling of space charges is positively used for the shift operation as indicated in U.S. 4,132,924 by Yamaguchi et al. The cause is considered to be that abnormal charges accumulate under the polarized condition at the surface of dielectric layer corresponding to the electrodes in both ends or a shift channel due to the repeated shift operations. Figure 1 shows schematically the distribution of such charges.

In this figure, the horizontal axis represents the shift channel with the right side of the Figure considered as the edge of entry, while the voltage is represented along the vertical axis. Such deviation of wall charges becomes distinctive due to the repeated shift operation and when it exceeds a certain value, the abnormal field resulting from these abnormal wall charges induces an avalanche phenomenon in the vicinity, in combination with an external field, such as the shift voltage, and thereby abnormal discharge not related with the display data, as explained above, occurs.

It is sufficient to give to the abnormally accumulated charge the possibility to disappear through the electrodes at both ends of shift channel in order to avoid such abnormal discharge. For example, in the gas discharge panel disclosed by the above-mentioned US 3,781,600 accumulation of charges is prevented by exposing the electrodes at both edges of a shift channel directly in the gas discharge space. However, the use of exposed electrodes causes the electrode material to be subject to sputtering due to

impact of ion during discharge or causes oxidation of the electrodes during the baking process of the sealing material when sealing the discharge gas space.

Anyhow, employment of such exposed electrodes brings about a disadvantage in that operating life is curtailed due to a change of discharge characteristic at the area near the pertinent electrodes. In addition, another problem consists in that the upper limit of write voltage margin is lowered. Namely, when the
10 write voltage is applied to the exposed write electrodes, a heavy current flows for a comparatively long period and therefore an intensive discharge continues for a comparatively long period at the write discharge cells defined by the write electrodes. Such discharge causes
15 unwanted discharge in the adjacent shift discharge cells. Consequently, it is necessary to keep the upper limit of said write voltage to a lower value.

On the other hand, the specification of the patent application U.S. Serial No. 213,464, entitled "Self-Shift Type Gas Discharge Panel" by Shinoda et al, assigned to the same assignee as the assignee of the present invention proposes to provide a pin hole or crevice for conducting charges to the dielectric layer corresponding to the electrodes at the two edges of
25 a shift channel. However, such a charge elimination structure brings about problems; in particular, it is difficult to form a panel having homogeneous characteristics with excellent reproduceability and also in this case, although it is not distinguishable, the electrodes are oxidated due to the existence of crevice.
30

The object of the invention is to provide a new type self-shift gas discharge panel not showing the above-mentioned drawbacks of the conventional drive method and panel structure. More particularly, the
35 object of the invention is to provide a practical

panel structure avoiding accumulation of abnormal charges at least at both edges of a shift channel.

These objects are attained by means of a panel of the type defined at the beginning of the description and characterized in that charge leak conductive layers are provided adjacent to the discharge cell position at least at both edges of the shift channel including said write discharge cell. With such a structure, the charges are eliminated by leaking through this conductive layer.

Other objects and characteristics of the present invention will be made further apparent from the description of various embodiments made with reference to the attached drawings wherein :

- Figure 1 shows a charge distribution for explaining accidental generation of abnormal charges in an AC memory driving type self-shift gas discharge panel,

- Figures 2 A to 2 C are respectively a first disassembled plan view, a sectional view and a second disassembled plan view of the principal portion of a self-shift gas discharge panel having a parallel electrode lead conductor structure, according to the present invention,

- Figure 3 shows the drive voltage waveforms for explaining the operation of panel shown in Figs. 2A - 2C,

- Figures 4A-4B and Figures 5A-5B schematically show partial plan views of portions of other embodiments of the panel in accordance with the present invention,

- Figures 6A to 6C respectively show a first disassembled plan view, a sectional view and a second disassembled plan view of the principal portion of a further embodiment of the panel according to

the present invention, and

- Figure 7 schematically shows the plan view of principal portion of still another embodiment of a panel according to the present invention.

Figures 2A to 2C show respectively a first partial plan view, a sectional view and a second partial plan view of the principal portion of a self-shift type gas discharge panel constituting an embodiment of the present invention. In this case, the electrode arrangement itself is similar to that shown in Fig. 7 of the U.S.P. No. 4,190,788 by Yoshikawa et al. Namely, two groups of Y shift electrodes y_{1i} and y_{2i} (i being a positive integer) alternately connected to two phases of buses Y_1 , Y_2 via parallel lead conductors (Fig. 2A), are provided on the internal side of a glass substrate 2 located opposite to a gas discharge space 1 and these electrodes are covered with a dielectric layer 3 and a surface layer 4 of MgO. On the internal side of another glass substrate 5, X shift electrodes x_{1j} and x_{2j} (j is positive integer) alternately connected to two other phases of buses X_1 , X_2 via parallel lead conductors (Fig. 2C) are similarly provided and covered with a dielectric layer 6 and a surface layer 7 of MgO. These X shift electrodes and Y shift electrodes are mutually opposed with an offset of a half pitch and define between them a shift discharge cell arrangement a_1 , b_1 , c_{1b} , d_1 , a_2 , ..., in such a form that the electrodes are sequentially used in common with the adjacent cells. The regular arrangement of such shift discharge cells forms in this case three shift channels 8a to 8c, and a write electrode 9 connected to a terminal W is respectively provided at the right edge of each of said shift channels, forming a write discharge cell W together with the first shift electrode y_{11} .

Such a structure differs from the panel structure described in the specification of the U.S.P. No. 4,190,788 cited above in that charge leak conductor layers llW_a , llW_b and llE_a , llE_b are provided as indicated in Fig. 2B, on the dielectric layers 3, 6 adjacent to the discharge cells at both ends of the shift channel including said write discharge cell W, namely adjacent to the position of the write discharge cell W and to the position of the terminating shift discharge cell bn. It is desirable to form these conductor layers $llWa$, $llWb$, $llEa$, $llEb$ with a material which is comparatively stable even after the thermal process carried out for forming the panel and which does not contaminate the surface layer determining the basic discharge characteristic. For example, indium oxide (In_2O_3), tin oxide (SnO_2) and mixture of them (ITO) are recommended. In the case of this embodiment, In_2O_3 is used. Hereinafter, each In_2O_3 layer is called charge leak layer. The charge leak layers $llWa$, $llWb$, $llEa$, $llEb$ extend to an edge of the panel as shown in Figs. 2A and 2C in order to be connected to an external drive circuit and thereby clamped to a predetermined potential. In practice, they can be connected to a DC power supply but, in the embodiment shown, the layers $llWa$ and $llWb$ are connected to the bus X2, while the layers $llEa$ and $llEb$ are connected to the ground potential. In short, these charge leak layer causes charges to flow in order to reset the potential when charges accumulate on the surface.

Thus, as explained above, by providing the charge leak layer $llWa$, $llWb$, $llEa$ and $llEb$ on the dielectric layers 3, 6 adjacent to the cells at both edges of a shift channel, the wall charges which are not desired for shift discharge, on the dielectric layer corresponding to both end cells, are quickly

drained by the charge leak layer. Namely, abnormal charges which could cause a spurious discharge are not accumulated. The charge leak layers $11W$, $11E$ may be formed only at a single electrode substrate. Such structure will be explained more in detail in the case of the wall charge transfer type driving method explained previously. Figure 5 shows the drive voltage waveforms to be applied to the write electrode terminal W and to the shift bus, and which are given the corresponding symbols. In this figure, SP is the write and shift period and DP is display period. As is apparent from the drive voltage waveforms of Fig. 3, a positive write voltage V_W is applied to the write electrode 9 during the period $T0$ and the write discharge occurs. Therefore, minus wall charges are formed on the dielectric surface layer 7 corresponding to the pertinent write electrode and plus wall charges are formed on the dielectric layer surface 4 corresponding to the opposite shift electrode y_{11} . The successive shift operation is performed in such a way that the plus wall charges are transferred by sequentially dropping the voltage of successive shift electrodes from the shift voltage V_{sh} to the ground potential, the minus charges remaining on the cell surface after the shift operation. While such write operation and shift operation are repeated, the wall charges are neutralized by the polarity inversion in each operation at the intermediate shift discharge cell. Resultingly, accumulation of residual charges is comparatively less than as shown in Fig. 1 but the portion corresponding to the write electrodes allows accumulation of minus charges and is therefore charged negatively, while the shift edge portion allows accumulation of plus charges transferred and is positively charged. But, by the

provision of the charge leak layers 11Wa, 11Wb, 11Ea,
11Eb on the dielectric layer in the vicinity of the
write cell W and of the terminal shift cell bn,
according to the present invention, the minus charges
5 appearing with the discharge nearly all accumulate
on the charge leak layers 11Wa, 11Wb, which is exposed
to the gas space, and are thereafter drained to said
bus X₂. Meanwhile, the plus charges used are nearly all
accumulated on the charge leak layers 11Ea, 11Eb and
10 therefrom drained to the ground potential source.
As a result, abnormal charges which may cause a spurious
discharge are not accumulated on the dielectric surface
layer corresponding to said both edge cells. The shift
voltage being applied to the charge leak layers 11Wa,
15 11Wb in the write side, this voltage does not cause
any discharge at the area facing to the charge leak
layers.

A method of manufacturing such a panel
will now be described. At first, an electrode conductor
20 made of three layers respectively of chrome (Cr) with a
thickness of 750Å, copper (Cu) with a thickness of 2µm,
and chrome (Cr) with a thickness of 750Å, is formed by a
sputtering process on the glass substrates 2 and 5. Then,
the surface Cr layer is removed by etching except in the
25 area located outside of the sealing part after the
assembling of the panel. As a result, an electrode
conductor consisting of two layers of Cr/Cu is formed.
Then, the shift electrodes Y_{1i}, Y_{2i}, X_{1j}, X_{2j} and the
write electrode 9 as shown in Figures 2A to 2C are formed
30 by carrying out a patterning/etching process in accord-
ance with the desired electrode pattern. Thereafter,
the dielectric layers 3, 6 of Al₂O₃ having a thickness
of 5 to 10 µm are formed on the electrodes, forming a
substrate, by the vacuum evaporation method. The panel
35 manufacturing process up to this step is known and the

above explanation refers to the thin film forming technology. But a structure obtained by applying a known thick film technology (for example, combination of electrodes formed by Au paste and the dielectric layer formed by a low melting point glass) may also be used.

Next, an evaporation mask having apertures matching the shape of the charge leak layers 11Wa, 11Wb, 11Ea, 11Eb is disposed on the dielectric layers 3, 6, and a layer of In_2O_3 having a thickness of 2000 to 10000 \AA is deposited by an evaporation method under these conditions.

Thereby, the charge leak layers 11Wa, 11Wb, 11Ea, and 11Eb as shown in Figs. 2A to 2C are formed on the dielectric layers. As a variant, it is also possible to deposit In_2O_3 on the entire surface of the dielectric layers 3, 6, then to coat it with a resist layer which is thereafter exposed and developed, forming a patterning film, and which is etched by an HCl solution. Thus, charge leak layers having the specified shape can be obtained.

Thereafter, a low melting point glass for sealing is screen-printed around the glass substrate and it is temporarily baked at a temperature of about 420°C in order to form the sealing portion 12. In addition, the MgO layers are deposited by an evaporation process with the charge leak layers 11Wa, 11Wb, 11Ea and 11Eb being covered by an evaporation mask. Thus, the surface layers 4, 7 having a thickness of about 5000 \AA can be formed only on the surface portion of the dielectric layers corresponding to the electrodes.

A pair of glass substrates 2 and 5 thus formed are arranged opposingly by means of spacers (not illustrated) so that a gap (discharge space) of about 90 to 110 μm is provided between them. Successively

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the sealing material is baked and said discharge space is filled with discharge gas, thus completing the above-described self-shift type gas discharge panel.

The In_2O_3 layer which forms the charge leak layers 11Wa, 11Wb, 11Ea, 11Eb does not contaminate the MgO surface layers 4, 7 under thermal influence even if the sealing material is baked. Therefore, the surface layer ensures the desired low voltage drive and stabilized discharge characteristic.

10 The above description relates only to a particular embodiment of the present invention and this invention is not limited to this embodiment and encompasses various modifications and extensions. Other embodiments are mentioned hereinbelow.

15 1) The charge leak layers may be provided on the surface of the dielectric layers, except in the zones corresponding to the electrodes defining each of all the discharge cells of a shift channel, as illustrated by the hatched portion 11S of Figs. 4A and 4B which are partial plan views showing typical Y electrodes. Such structure makes it possible to drain the unwanted extra charges not desired for the shift discharge in the area of the center of a channel and ensures more stable discharge characteristic.

20 25 2) The charge leak layers 11W, 11E may show the form indicated by dash lines on Figs. 5A and 5B which represent the write side and noble metals such as Au, Pt can also be used as constituting material. When a charge leak layer consisting of aluminium is used, since the surface resistance coefficient is about 0.1 ohm/square which is very small as compared with that of SnO_2 , In_2O_3 mentioned above, the charge leak layer can be kept almost to the same potential for the entire part thereof from the end portion adjacent to said edge of the panel to which the charge leak layer extends for being voltage

clamped, to the opposite end portion. Therefore, this structure is very effective for giving the same charge leak effect to all of the shift channel groups arranged in parallel in the case of a multi-row display panel having a plurality of shift channels.

5 3) In the embodiment of Figs. 2A to 2C, the lead-out wires for connecting the charge leak layers to the supply source are formed on the both glass substrates in order to maintain the charge leak layers 11Wa, 11Wb, 10 11Ea, 11Eb provided at both edges of the shift channel to a predetermined potential. However, the lead-out wire may be provided only on a single glass substrate 5 as shown in Figs. 6A to 6C, thus reducing the number of such lead-out wires. Figs. 6A to 6C are similar 15 to Figs. 2A to 2C except for the charge leak layer lead-out structure. Therefore, only the lead-out structure will be explained in detail. Namely, as shown in Fig. 6B, a conductive member 13 is provided between the charge leak layers 11Ea and 11Eb, and between 11Wa and 11Wb in order to short-circuit them. This conductive member 13 for short-circuiciting is, for example, cylindrically shaped and made of a conductive material such as nickel, aluminium or stainless steel and is provided also as the spacer between the charge leak 20 layers 11Ea and 11Eb, and between 11Wa and 11Wb when assembling the panel by means of the sealing material 12. When the charge leak layers 11Ea and 11Eb, as well as 25 11Wa and 11Wb are short-circuicited by said short-circuiciting member 13, the lead-out wires provided at the edge of one glass substrate, for example 2, in order 30 to maintain each of the charge leak layers 11Ea and 11Wa to the predetermined potential are no longer necessary. As a result, only the lead-out wires provided on the other glass substrate 5 and connected to the conductors 35 11E, 11W forcharge leak are necessary. Thus, for the

connection of each of the charge leak layers 11Wa, 11Wb and 11Ea, 11Eb, to the respective predetermined voltage sources as in the case of Figs. 2A-2C, lead-out wires provided at the edge of the glass substrate 5, are only required (Fig. 6C).

4) In the above embodiment of Figs. 2A-2C and 6A-6C, the charge leak layers 11Ea and 11Wa, or 11Eb and 11Wb are each connected to a respective predetermined voltage source. By contrast, Fig. 7 shows a Y electrode 10 substrate, where the connection of each charge leak layers 11Ea and 11Wa to a respective voltage source is not necessary, the charge leak layers being so configurated that they are coupled to each other on the substrate.

15 5) The charge leak layers may be formed directly on the glass substrate. Namely, the charge leak layers 11Wa, 11-Ea, 11Eb having an inner surface not facing the electrodes, a dielectric layer for covering electrodes is not required in the corresponding area. Resultingly, 20 such charge leak layers can be directly provided on the glass substrate.

25 6) The present invention can be applied, as explained precedingly, in addition to the self-shift type gas discharge panel having the parallel electrode lead conductor structure, to a panel having the meander electrode structure disclosed in the above-mentioned U.S.P. No. 4,132,924, a panel having an electrode structure where the number of electrode groups is increased up to 2 groups x 2 groups or more, a panel 30 having a parallel electrode structure, a panel having a matrix electrode structure or monolithic structure, etc...

35 In short, as is apparent from above description, the present invention discloses an AC memory driving type self-shift type gas discharge

panel wherein the charge leak conductive layer which prevents accumulation of abnormal wall charges is provided in the vicinity of the discharge cells at least at both edges of a shift channel, and thereby accidental misdischarge caused by deviated abnormal charges which is peculiar to the self-shift panel can be prevented. In addition, since the electrodes at both edges of said shift channels are protected by the dielectric layers, they are not sputtered during discharge and not oxidized when the gas space is sealed. Moreover, the material selected for the charge leak layer is stable even after the thermal process carried out for forming the panel and does not contaminate the dielectric surface layer. Therefore, stable characteristic and long operating life can be assured. This invention is very effective, in such a point, for improving the performance of the AC memory driving type self-shift type gas discharge panel.

CLAIMS

1. Self-shift type gas discharge panel with at least one shift channel consisting of a regular arrangement of a plurality of shift discharge cells formed by opposing shift electrodes which are sequentially and regularly connected to a plurality of bus, which face a gas discharge space and which are provided with a coverage of dielectric layer for charge accumulation, and with a write discharge cell 10 formed by the provision of a write electrode at one end of said shift channel, characterized in that charge leak conductive layers (11Wa, 11Wb, 11Ea, 11Eb) are provided adjacent to the discharge cell positions at least at both edges of the shift channel including said 15 write discharge cell.
2. Self-shift type gas discharge panel according to claim 1, characterized in that the charge leak conductive layers (11Wa, 11Wb, 11Ea, 11Eb) are provided on the dielectric layer (3,6) for charge 20 accumulation in a form independent of the electrodes defining the discharge cells adjacent thereto.
3. Self-shift type gas discharge panel according to claim 1, characterized in that the charge leak conductive layers (11Wa, 11Wb) are formed of a 25 material including at least one of the indium oxide and tin oxide.
4. Self-shift type gas discharge panel according to claim 1, characterized in that the charge leak conductive layers (11Wa, 11Wb, 11Ea, 11Eb) are made 30 of aluminium.
5. Self-shift type gas discharge panel according to any one of the preceding claims, characterized in that the charge leak conductive layers (11Wa, 11Wb, 11Ea, 11Eb) provided at both edges of 35 shift channel are provided in pair opposing to a pair

of insulating substrates (2,5).

6. Self-shift type gas discharge panel according to any one of the preceding claims, characterized in that the charge leak conductive layers (11Wa, 11Wb, 11Ea, 11Eb) are respectively clamped to a predetermined voltage.

5 7. Self-shift type gas discharge panel according to any one of the preceding claims, characterized in that the charge leak conductive layers provided on a same substrate are mutually coupled.

10 8. Self-shift type gas discharge panel according to claim 5, characterized in that two pairs of charge leak conductive layers (11Wa, 11Wb; 11Ea, 11Eb, arranged opposingly are respectively clamped to predetermined voltages.

15 9. Self-shift type gas discharge panel according to claim 6, characterized in that the charge leak conductive layers (11Wa, 11Wb,) provided on the side of the write discharge cell (W) at the beginning edge of the shift channel are connected in common to a bus (X2) for the supply of shift voltage to selected shift electrodes, while the charge leak conductive layers (11Ea, 11Eb) provided on the side of a final shift discharge cell (bn) at the terminating edge of the shift channel are connected to a reference voltage source.

20 10. Self-shift type gas discharge panel according to claim 8, characterized in that a conductive material (13) is inserted between two pairs of charge leak conductive layers (11Wa-11Wb, 11Ea-11Eb) arranged opposingly in order to short-circuit them.

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Fig-1

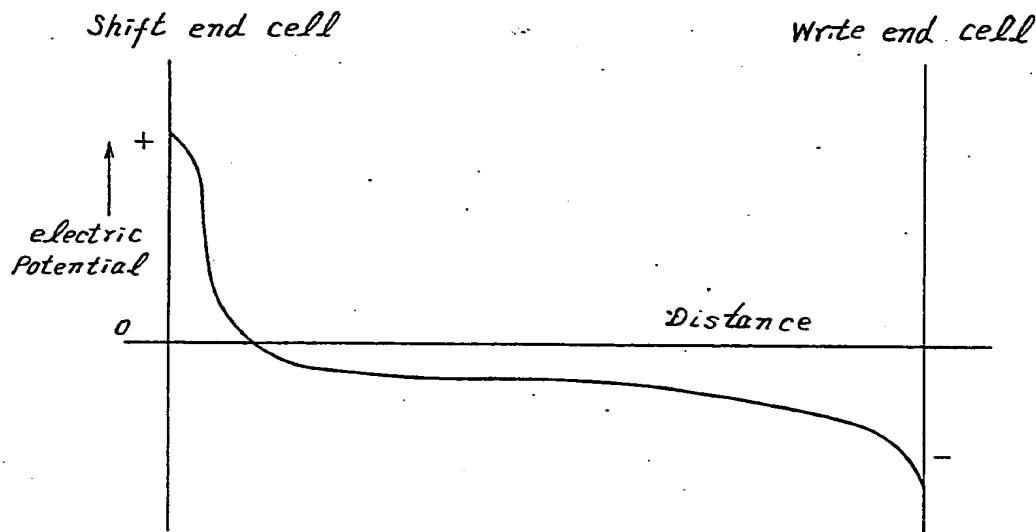
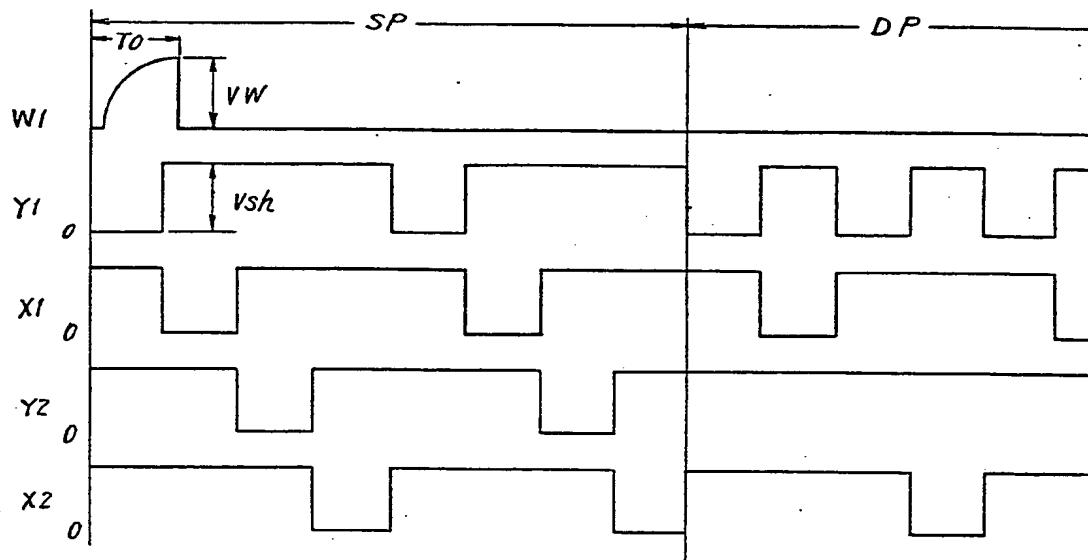


Fig-3



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Fig-2A

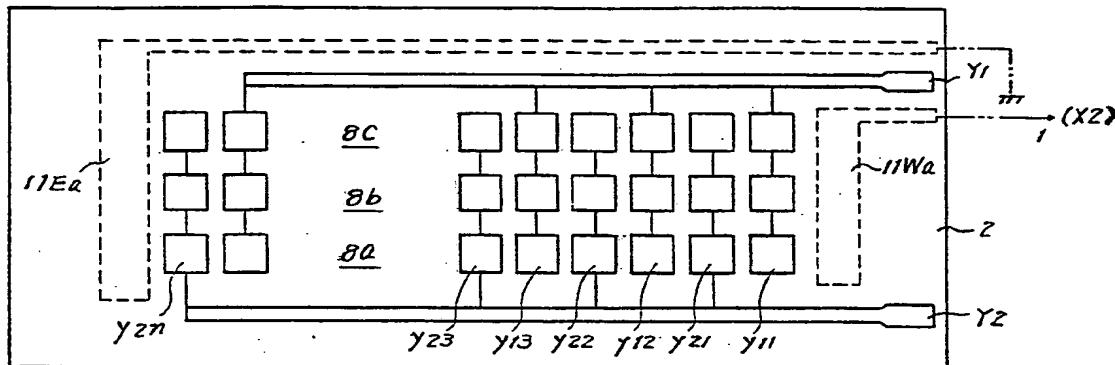


Fig-2B

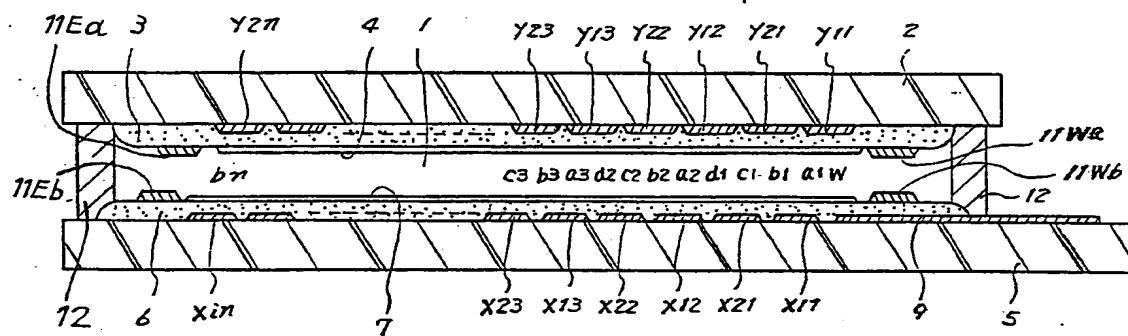
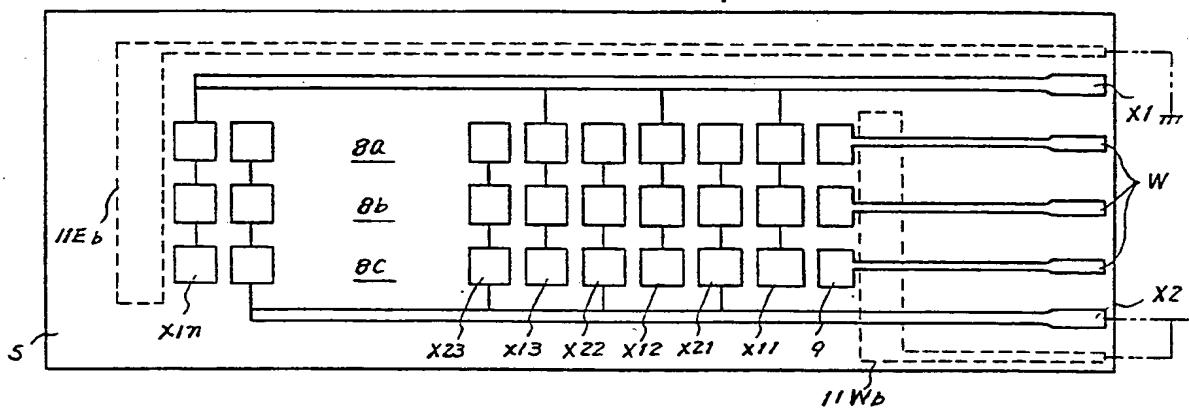


Fig-2C



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Fig-4A

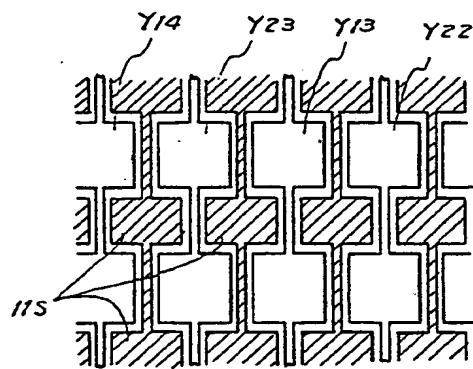


Fig-4B

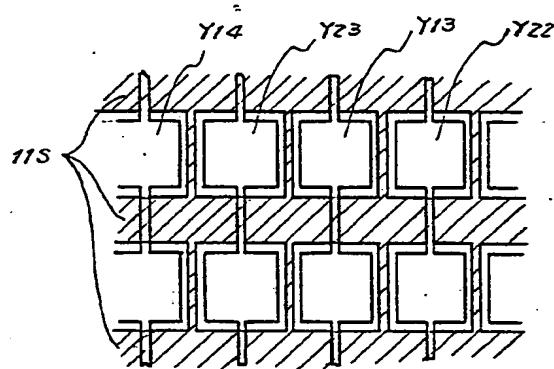


Fig-5A

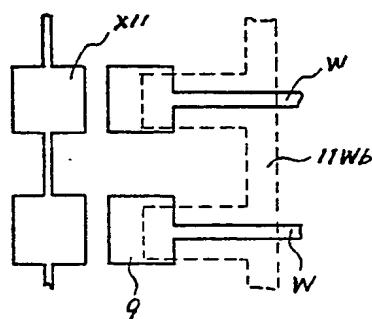
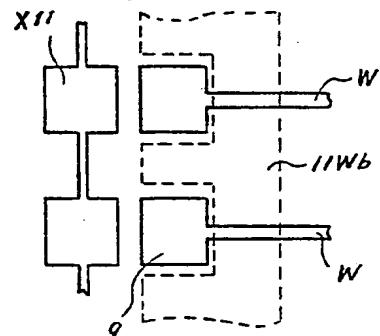


Fig-5B



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Fig-5A

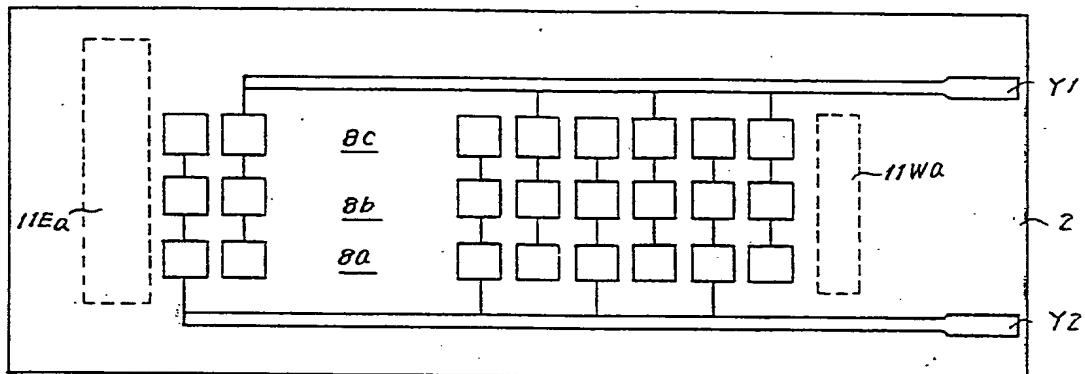


Fig-5B

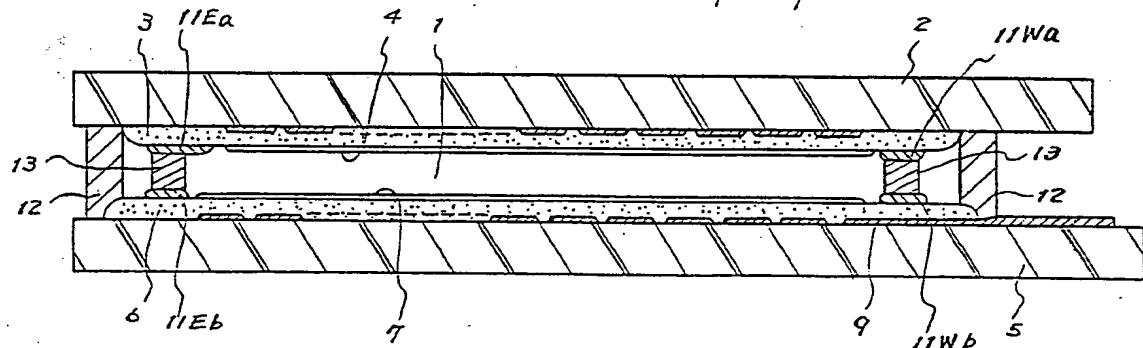
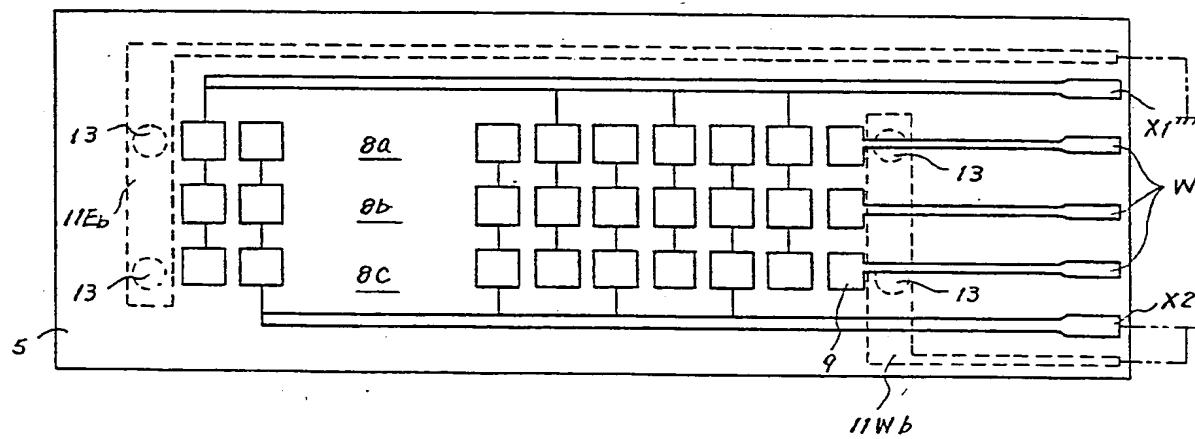


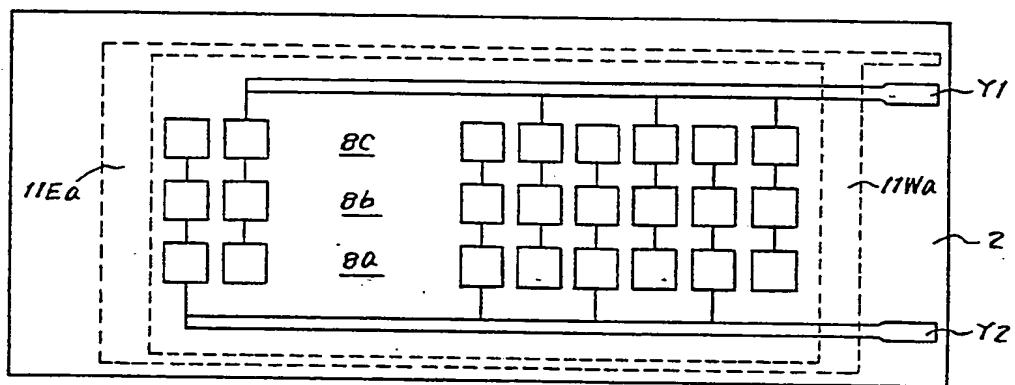
Fig-5C



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Fig-7



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